

Notice of References Cited	Application/Control No. 10/581,852	Applicant(s)/Patent Under Reexamination ASADA, NORIHIRO	
	Examiner Reema Patel	Art Unit 2812	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,188,702	02-1993	Takayama et al.	216/18
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP2003-121468 (english)	04-2003	Japan	Nakamura et al.	G01R 1/073
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kovacs et al., "Bulk Micromachining of Silicon", August 1998, Proceedings of the IEEE, Vol. 86, No. 8, pp. 1536-1551.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.